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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of:

OSUDA, et al.

Group Art Unit: 1724

Serial No.: 10/675,939

Examiner: Robert J. Popovics

Filed: October 2, 2003

P.T.O. Confirmation No.: 5925

For: METHOD AND APPARATUS FOR REUSE OF ABRASIVE FLUID USED IN THE  
MANUFACTURE OF SEMICONDUCTORS

**AMENDMENT AND RESPONSE TO THE RESTRICTION  
REQUIREMENT AND ELECTION OF SPECIES**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 18, 2005

Sir:

This is in response to the Office Action of June 17, 2005, requiring restriction among  
six alleged inventions under the provisions of 35 USC § 121.

Amendments to the Claims begin on page two of this paper.

Remarks begin on page 12 of this paper.